

# **2nd Geant4 International school and ROOT analysis concepts**

INFN-LNS, Catania (Italy)

19<sup>th</sup> November 2014

## **Physics in Geant4: Particles, processes, cuts and models**

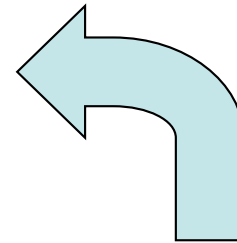
**Geant 4 tutorial**



# Introduction

Mandatory user classes in a Geant4:

- **G4VUserPrimaryGeneratorAction**
- **G4VUserDetectorConstruction**
- **G4VUserPhysicsList**



*Particles, physics processes and cut-off parameters to be used in the simulation must be defined in the **G4VUserPhysicsList** class*

# Why a physics list?

- “*Physics is physics* – shouldn't Geant4 provide, as a default, a complete set of physics that everyone can use?”
- **NO:**
  - Software can only capture Physics through a modelling
    - No unique Physics modelling
      - Very much the case for hadronic physics
      - But also the electromagnetic physics
      - Existing models still evolve and new models are created
    - Some modellings are more suited to some energy ranges
      - Medical applications not interested in multi-GeV physics in general
      - HEP experiments not interested in effects due to atomic shell structure
  - computation speed is an issue
    - a user may want a less-detailed, but faster approximation

# Why a physics list?

- For this reason Geant4 takes an atomistic, rather than an integral approach to physics
  - provide many physics independent components (processes)
  - user selects these components in custom physics lists
- This physics environment is built by the user in a flexible way:
  - picking up the particles he/she wants
  - picking up the physics to assign to each particle
- User must have a good understanding of the physics required
  - omission of particles or physics could cause errors or poor simulation

*User may also use some provided “ready-to-use” physics lists*

# G4VUserPhysicsList: required methods

## **ConstructParticle () :**

- choose the particles you need in your simulation, define all of them here

## **ConstructProcess () :**

- for each particle, assign all the physics processes relevant to your simulation
  - What's a process ?
    - a class that defines how a particle should interact with matter, or decays
      - » it's where the physics is!

## **SetCuts () :**

- set the range cuts for secondary production
  - What's a range cut ?
    - a threshold on particle production
      - » Particle unable to travel at least the range cut value are not produced

# Particles: basic concepts

There are three levels of class to describe particles in Geant4:

- **G4ParticleDefinition**
  - define a particleaggregates information to characterize a particle's properties (name, mass, spin, etc...)
- **G4VDynamicParticle**
  - describe a particle interacting with materialsaggregates information to describe the dynamic of particles (energy, momentum, polarization, etc...)
- **G4VTrack**
  - describe a particle travelling in space and timeincludes all the information for tracking in a detector simulation (position, step, current volume, track ID, parent ID, etc...)

# Definition of a particle

Geant4 provides the **G4ParticleDefinition** definition class to represent a large number of elementary particles and nuclei, organized in six major categories:

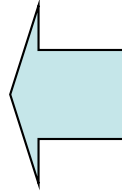
***lepton, meson, baryon, boson, shortlived and ion***

- Each particle is represented by its own class, for instance **G4Electron**, which is derived from **G4ParticleDefinition**
- Properties characterizing individual particles are “read only” and can not be changed directly

User must define **all particles** type which are used in the application: not only **primary particles** but also all other particles which may appear as **secondaries** generated by the used physics processes

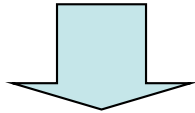
# Constructing particles

Due to the large number of particles can be necessary to define, this method sometimes can be not so comfortable

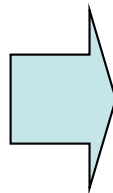


```
void MyPhysicsList::ConstructParticle  
(  
{  
    G4Electron::ElectronDefinition();  
    G4Proton::ProtonDefinition();  
    G4Neutron::NeutronDefinition();  
    G4Gamma::GammaDefinition();  
    ....  
}
```

It is possible to define **all** the particles belonging to a **Geant4 category**:



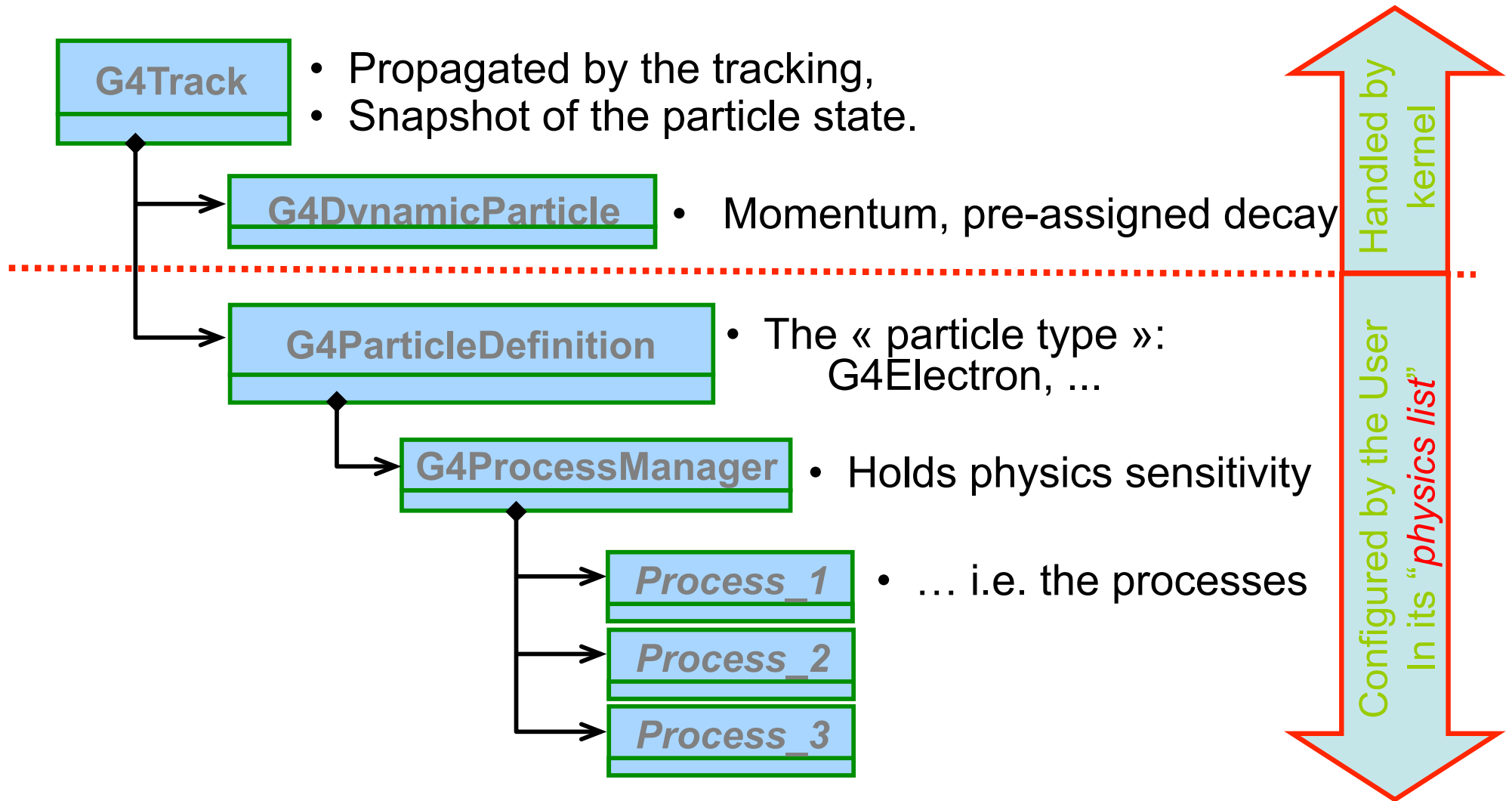
- **G4LeptonConstructor**
- **G4MesonConstructor**
- **G4BarionConstructor**
- **G4BosonConstructor**
- **G4ShortlivedConstructor**
- **G4IonConstructor**



```
void  
MyPhysicsList::ConstructBaryons()  
{  
    // Construct all baryons  
    G4BaryonConstructor pConstructor;  
    pConstructor.ConstructParticle();  
}
```



# From particles to processes



# Processes

*Physics processes describe how particles interact with materials*

Geant4 provides seven major categories of processes:

- Electromagnetic
- Hadronic
- Decay
- Optical
- Photolepton\_hadron
- Parameterization
- Transportation

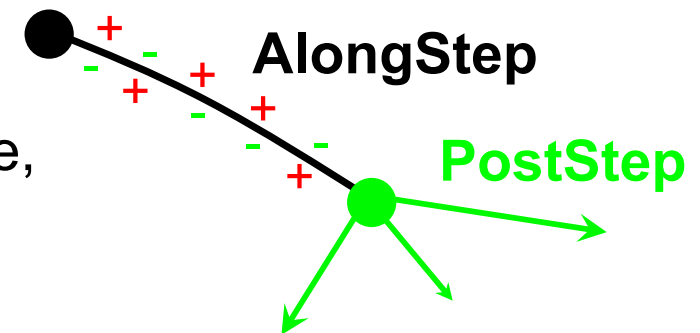
A process does two things:

- decides when and where an interaction will occur
  - method: **GetPhysicalInteractionLength()** → *limit the step*
  - this requires a cross section
  - for the transportation process, the distance to the nearest object
- generates the final state of the interaction (changes momentum, generates secondaries, etc.)
  - method: **DoIt()**
  - this requires a model of the physics

# G4Vprocess class

Physics processes are derived from the **G4VProcess** base class

- Abstract class defining the common interface of **all processes** in Geant4:
  - Used by all physics processes (also by the transportation, etc...
  - Defined in **source/processes/management**
- Define **three kinds of actions**:
  - **AtRest** actions:
    - Decay,  $e^+$  annihilation ...
  - **AlongStep** actions:
    - To describe continuous (inter)actions, occurring along the path of the particle, like ionisation;
  - **PostStep** actions:
    - For describing point-like (inter)actions, like decay in flight, hadronic interactions ...



*A process can implement a combination of them (decay = AtRest + PostStep)*

# Example processes

- Discrete process: **Compton Scattering, hadronic inelastic, ...**
  - step determined by cross section, interaction at end of step
    - PostStepGPIL(), PostStepDolt()
- Continuous process: **Cerenkov effect**
  - photons created along step, roughly proportional to step length
    - AlongStepGPIL(), AlongStepDolt()
- At rest process: **mu- capture at rest**
  - interaction at rest
    - AtRestGPIL(), AtRestDolt()

*pure*

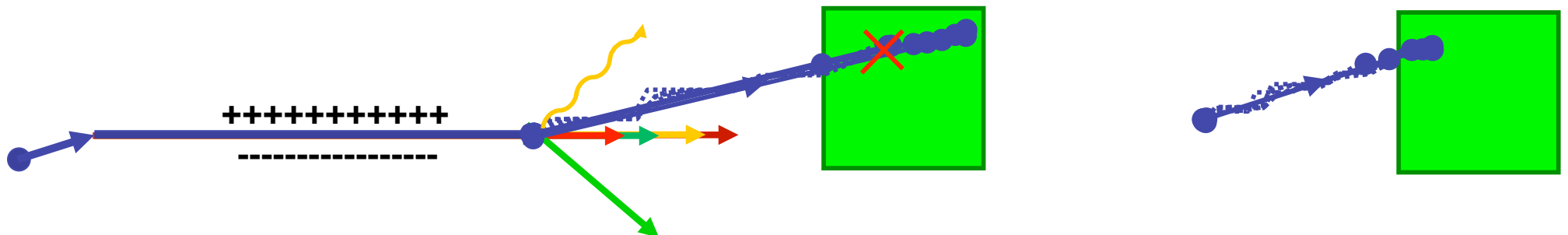
- Rest + discrete: **positron annihilation, decay, ...**
  - both in flight and at rest
- Continuous + discrete: **ionization**
  - energy loss is continuous
  - knock-on electrons ( $\delta$ -ray) are discrete

*combined*

# Handling multiple processes

- STAGE 1: a particle is shot and “transported”
- STAGE 2: all processes associated to the particle propose a geometrical step length (depends on process cross-section)
- STAGE 3: The process proposing the shortest step “wins” and the particle is moved to destination (if shorter than “Safety”)
- STAGE 4: All processes “along the step” are executed (e.g. ionization)
- STAGE 5: “post step” phase of the process that limited the step is executed  
New tracks are “pushed” to the stack
- STAGE 6: If  $E_{\text{kin}}=0$  all “at rest” processes are executed; if particle is stable the track is killed. Else:
- STAGE 7: A new step starts and sequence repeats...

*Processes return a “true path length”. The multiple scattering “virtually folds up” this true path length into a shorter “geometrical” path length. Transportation process can limit the step to geometrical boundaries.*

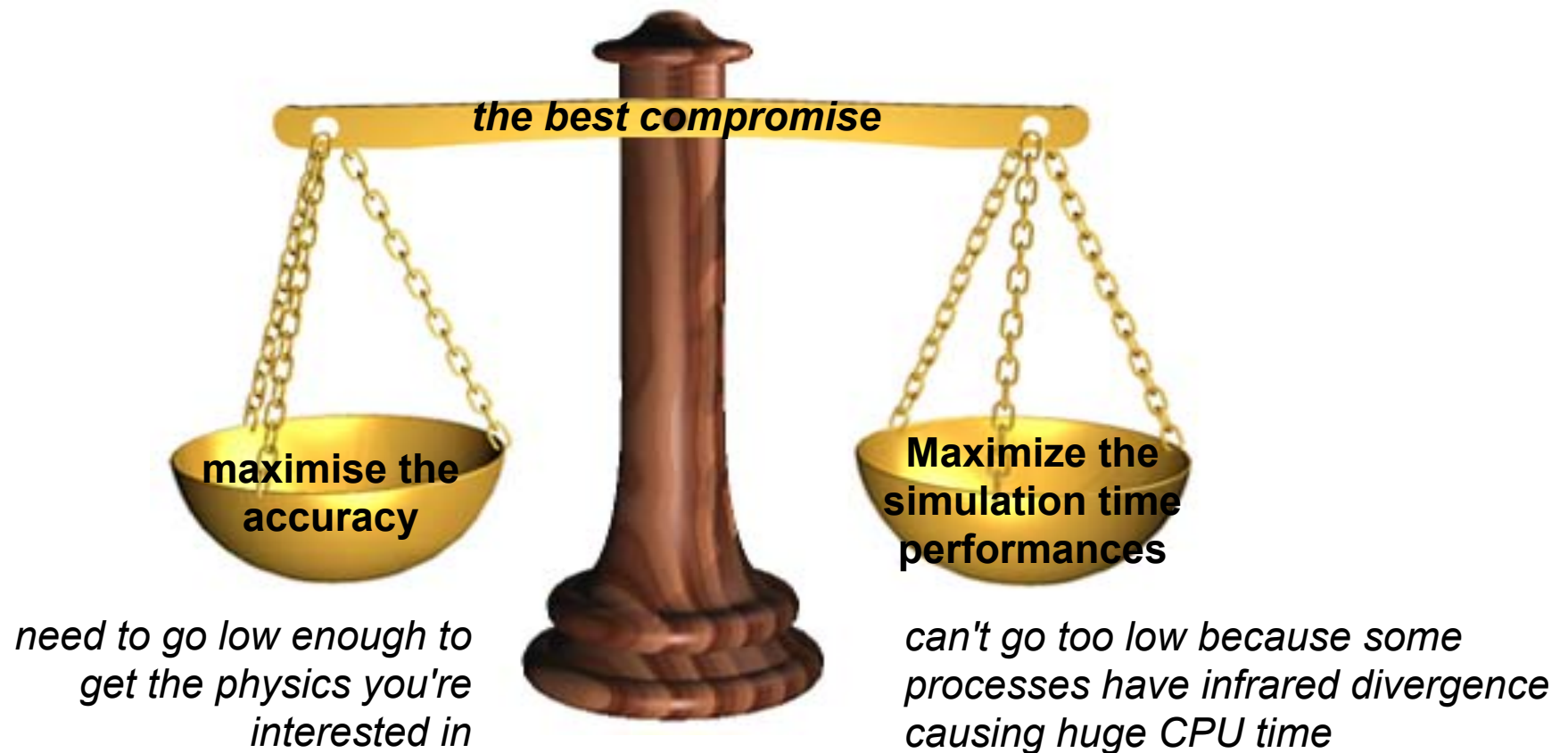


# Production thresholds: cut

Each simulation developer must answer the question:  
**how low can you go?**

- should I produce (and track) everything or consider thresholds?

This is a balancing act:



# Production thresholds: cut

- The **traditional Monte Carlo** solution is to impose an absolute cutoff in energy:
  - particles are stopped when this energy is reached
  - remaining energy is dumped at that point
- But, such a cut may cause **imprecise stopping location** and deposition of energy
- There is also a **particle dependence**
  - range of 10 keV p in Si is different from range of 10 keV e- in Si
- And a **material dependence**
  - suppose you have a detector made of alternating sheets of Pb and plastic scintillator
  - if the cutoff is OK for Pb, it will likely be wrong for the scintillator which does the actual energy deposition measurement

# Production thresholds: cut

- In Geant4 there are no tracking cuts
  - *particles are tracked down to a zero range/kinetic energy*
- Only production cuts exist
  - i.e. cuts allowing a particle to be born or not
  - Applied to: **gamma**, **electron**, **positron**, **proton**
- *Why are production cuts needed ?*

Some electromagnetic processes involve infrared divergences

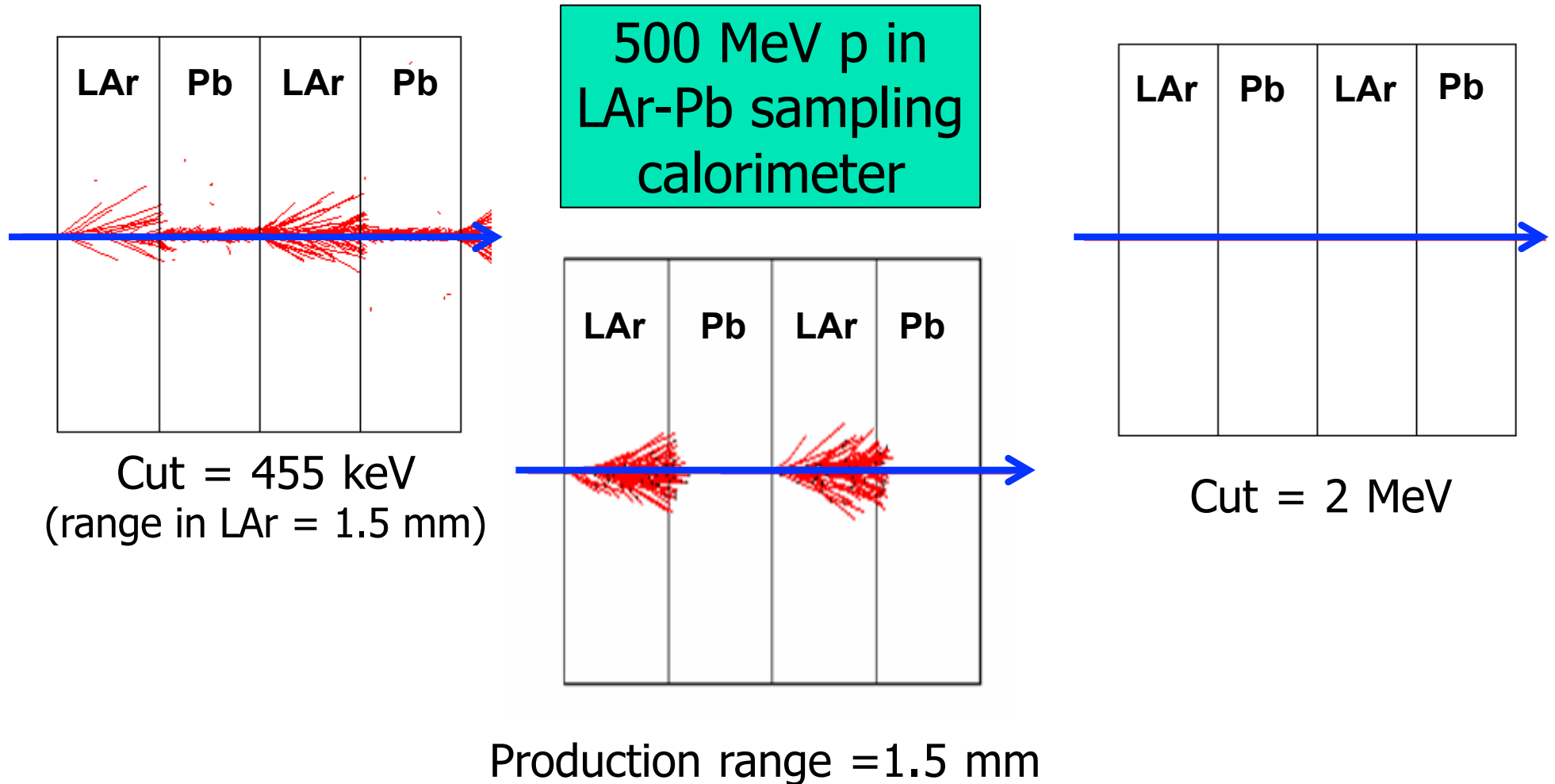
- this leads to a huge number of smaller and smaller energy photons/electrons (such as in Bremsstrahlung, d-ray production)
- production cuts limit this production to particles above the threshold
- the remaining, divergent part is treated as a continuous effect (i.e. AlongStep action) → energy balance is preserved



# Production thresholds: cut

- Geant4 solution: impose a “range” **production threshold**
  - this threshold is a **distance**, not an energy
  - default = 1 mm
- Only one production threshold cut is uniformly set
- Production threshold is internally converted to an energy threshold, **depending on particle type and material**
- When primary no longer has enough energy to produce secondaries which travel at least 1mm, two things happen:
  - discrete energy loss stops (no more secondaries produced)
  - the primary is tracked down to zero energy using continuous energy loss
    - Stopping location is therefore correct

# Production thresholds: cut



Threshold in range: 1.5 mm

455 keV electron energy in liquid Ar  
2 MeV electron energy in Pb

# Cuts per region

- In a complex detector there may be many different sub-detectors involving
  - finely segmented volumes
  - very sensitive materials
  - large, undivided volumes
  - inert materials
- The same cut may not be appropriate for all of these
  - user can define regions (logical volume envelopes) and assign different cuts for each region
- Warning: this feature is for users who are
  - simulating complex detectors
  - experienced at simulating EM showers in matter

**Thanks for your attention**